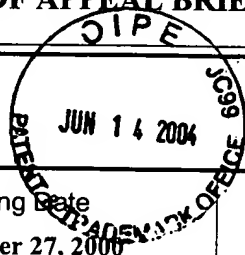


IFW AFF 2811 \$

TRANSMITTAL OF APPEAL BRIEF (Large Entity)

Docket No.  
YOR919990153US2

In Re Application Of: Chen, et al.



Serial No.  
09/748,256

Filing Date  
December 27, 2000

Examiner  
Ori Nadav

Group Art Unit  
2811

Invention: METHOD FOR FABRICATING COMPLEMENTARY METAL OXIDE SEMICONDUCTOR (CMOS) DEVICES ON A MIXED BULK AND SILICON-ON-INSULATOR (SOI) SUBSTRATE

TO THE COMMISSIONER FOR PATENTS:

Transmitted herewith in triplicate is the Appeal Brief in this application, with respect to the Notice of Appeal filed on

The fee for filing this Appeal Brief is: \$330.00

- ☐ A check in the amount of the fee is enclosed. (Previously submitted on April 19, 2004)
- ☐ The Director has already been authorized to charge fees in this application to a Deposit Account.
- ☒ The Director is hereby authorized to charge any fees which may be required, or credit any overpayment to Deposit Account No. 50-0510

Signature

Dated: 6/14/04

Phillip E. Miller  
Registration No. 46,060  
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8321 Old Courthouse Road  
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Vienna, Virginia 22182-3817

I certify that this document and fee is being deposited on \_\_\_\_\_ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature of Person Mailing Correspondence

Typed or Printed Name of Person Mailing Correspondence

CC: